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	Application No.	Applicant(s)	į
Notice of Allowability	10/643,583	DAVID, JEFFREY DRUE	
	Examiner	Art Unit	
	M Rachuba	3723	
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap or other appropriate communication GHTS. This application is subject	oplication. If not incl n will be mailed in d	uded ue course. <b>THIS</b>
1. A This communication is responsive to communication filed 3	00 August 2004.		
2. X The allowed claim(s) is/are <u>1-24</u> .			
3. A The drawings filed on 24 August 2004 are accepted by the	Examiner.		
<ul> <li>4. ☐ Acknowledgment is made of a claim for foreign priority una) ☐ All b) ☐ Some* c) ☐ None of the:  1. ☐ Certified copies of the priority documents have 2. ☐ Certified copies of the priority documents have 3. ☐ Copies of the certified copies of the priority documents have international Bureau (PCT Rule 17.2(a)).  * Certified copies not received:  Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.</li> <li>5. ☐ A SUBSTITUTE OATH OR DECLARATION must be submitinformal pattent application (PTO-152) which give including changes required by the Notice of Draftspers  1) ☐ hereto or 2) ☐ to Paper No./Mail Date  (b) ☐ including changes required by the attached Examiner's Paper No./Mail Date  Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the capacitation of the deposit attached Examiner's comment regarding REQUIREMENT in the capacitation of the deposit attached Examiner's comment regarding REQUIREMENT in the capacitation of the deposit attached Examiner's comment regarding REQUIREMENT in the capacitation of the deposit attached Examiner's comment regarding REQUIREMENT in the capacitation of the capac</li></ul>	been received.  been received in Application No cuments have been received in this  of this communication to file a reply ENT of this application.  itted. Note the attached EXAMINE as reason(s) why the oath or declar at be submitted.  on's Patent Drawing Review ( PTC)  s Amendment / Comment or in the  84(c)) should be written on the draw he header according to 37 CFR 1.121  sit of BIOLOGICAL MATERIAL	e national stage apply complying with the R'S AMENDMENT of ation is deficient.  O-948) attached  Office action of tings in the front (not lid).  must be submitted	requirements or NOTICE OF
<ul> <li>Attachment(s)</li> <li>1. ☑ Notice of References Cited (PTO-892)</li> <li>2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date</li></ul>	5. Notice of Informal 6. Interview Summar Paper No./Mail D 7. Examiner's Amend 8. Examiner's Statem 9. Other	y (PTO-413), ate Iment/Comment	Allowance

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## **EXAMINER'S AMENDMENT**

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

- 2. The application has been amended as follows: This application is in condition for allowance except for the presence of claims 25-31 directed to an invention non-elected without traverse. Accordingly, claims 25-31 have been cancelled.
- 3. The following is an examiner's statement of reasons for allowance: the prior art of record does not disclose or fairly teach varying the sensor path across the substrate by rotating the substrate carrier at a rotation rate different than the rotation rate of the polishing pad. The closest prior art, US2001/0036793A1 to Wiswesser et al and US 2004/0152396A1 to Wiswesser et al, teach varying the sensor path across the substrate by reciprocating the substrate carrier across the pad. While both devices are capable of providing different rotation rates for the pad and carrier, both are clear that the sensor path depends on reciprocation of the carrier.
- 4. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to M Rachuba whose telephone number is **(571) 272-4493**. The examiner can normally be reached on Monday-Thursday from 8:30 AM to 3:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Joseph Hail, can be reached on (571) 272-4485. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

M. Rachuba
Primary Patent Examiner